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**\*BIBDATASHEET\***

Bib Data Sheet

**CONFIRMATION NO. 9165**

SERIAL NUMBER 10/620,452	FILING DATE 07/17/2003  RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 2003_0979
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**APPLICANTS**

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**\*\* CONTINUING DATA \*\*\*\*\* ✓F, LV**

This application is a DIV of 09/572,432 05/17/2000 PAT 6,615,854

**\*\* FOREIGN APPLICATIONS \*\*\*\*\* ✓F, LV**

JAPAN 11-139183 05/19/1999

**IF REQUIRED, FOREIGN FILING LICENSE GRANTED****\*\* 09/08/2003**

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	DRAWING 6	CLAIMS 13	CLAIMS 1
Verified and Acknowledged	Examiner's Signature  Initials 				

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**TITLE**

Wafer cleaning apparatus

 All Fees 1.16 Fees ( Filing ) 1.17 Fees ( Processing Ext. of time )

**FILING FEE** FEES: Authority has been given in Paper  
 No. \_\_\_\_\_ to charge/credit DEPOSIT ACCOUNT